



03500.014241

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
	:	Examiner: B. Talbot
NOBUHIRO ITO	)	
	:	Group Art Unit: 1762
Application No.: 09/505,627	)	
	:	
Filed: February 16, 2000	)	
	:	
For: MANUFACTURING METHOD OF)		
ELECTRON BEAM APPARATUS :		
AND SPACER, AND ELECTRON )		
BEAM APPARATUS :		October 4, 2005

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

THIRD INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the document listed on the enclosed Form PTO-1449. A copy of this document is enclosed.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicant's undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

A handwritten signature in dark ink, appearing to read "Jason M. Okun", written over a horizontal line.

Jason M. Okun  
Attorney for Applicant  
Registration No. 48,512

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